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MODULAR SYSTEMS AND METHODS FOR USING
SAMPLE PROCESSING DEVICES

ABSTRACT OF THE DISCLOSURE

Sample processing systems and methods of using those systems for
processing sample materials located in devices that are separate from the system
10 are disclosed. The sample processing systems include a rotating base plate on
which the sample processing devices are located during operation of the
systems. The systems also include connection apparatus that allow for rapid and
easy removal and/or replacement of base plates.

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